



DOCKET NO: VSEA 18-01

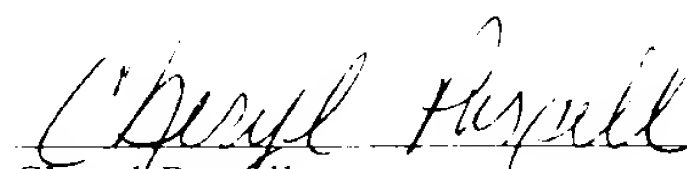
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Donald W. Berrian et al.
Serial No: 09/990,848
Confirmation No: 2772
Filed: November 21, 2001
For: HYBRID SCANNING SYSTEM AND METHODS FOR ION
IMPLANTATION
Examiner: Johnnie L. Smith
Art Unit: 2881

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The undersigned hereby certifies that this document is being placed in the United States mail with first-class postage attached, addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the 17th day of September, 2003.


Cheryl Purcell

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:


Petition for Extension of Time

A three-month extension of time to September 13, 2003 is requested for response to the Examiner's Office Action of March 13, 2003.

The extension fee of \$930.00 may be charged to deposit account No. 50-0896. If the amount is insufficient, please charge deposit account No. 50-0896. A duplicate of this Petition is enclosed.

09/18/2003 DTESSEM1 00000044 500896 09990848
01 FC:1253 930.00 DA

Respectfully submitted,
Donald W. Berrian et al., Applicants

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